Application/Control No. Applicant(s)/Patent Under Reexamination 10/656.353 HEGER ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Kin-Chan Chen 1765 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY US-5,198,072 03-1993 Gabriel, Calvin T. Α 216/59 US-5,653,894 08-1997 Ibbotson et al. В 216/59 US-2003/0000546 01-2003 Richardson et al. С 134/1.1 D US-6,303,044 10-2001 Koemtzopoulos et al. 216/59 Koemtzopoulos et al. Ε US-6,017,414 01-2000 156/345.25 US-5,169,407 12-1992 F Mase et al. 29/25.01 G US-US-Н US-US-US-K US-US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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